

Title (en)

METHOD FOR PRODUCING GLASS SUBSTRATE WITH ALUMINUM OXIDE-CONTAINING SILICON OXIDE FILM

Title (de)

VERFAHREN ZUR HERSTELLUNG EINES GLASSUBSTRATS MIT EINEM ALUMINIUMOXIDHALTIGEN SILICIUMOXIDFILM

Title (fr)

PROCÉDÉ DE PRODUCTION D'UN SUBSTRAT EN VERRE POURVU D'UN FILM EN OXYDE DE SILICIUM CONTENANT DE L'OXYDE D'ALUMINIUM

Publication

EP 2581351 A1 20130417 (EN)

Application

EP 11792500 A 20110608

Priority

- JP 2010134186 A 20100611
- JP 2011063178 W 20110608

Abstract (en)

To provide a process for producing a glass substrate provided with an aluminum oxide-containing silicon oxide film having a low refractive index and a high light transmittance, with good production efficiency, with which an aluminum oxide-containing silicon oxide film excellent in the moisture resistance can be directly formed on a glass substrate or a glass ribbon at high temperature. (1) A process for producing a glass substrate provided with an aluminum oxide-containing silicon oxide film, which comprises applying a coating liquid containing an organopolysiloxane and an organic aluminum complex to a glass substrate within a temperature range of from 400 to 650°C to form an aluminum oxide-containing silicon oxide film on the glass substrate, and (2) a process for producing a glass substrate comprising forming molten glass into a glass ribbon, annealing the glass ribbon and cutting it to produce a glass substrate, wherein a coating liquid containing an organopolysiloxane and an organic aluminum complex is applied to the glass ribbon at a position where the glass ribbon is within a temperature range of from 400 to 650°C to form an aluminum oxide-containing silicon oxide film on the glass ribbon.

IPC 8 full level

C03C 17/25 (2006.01); **C03C 17/00** (2006.01)

CPC (source: EP US)

C03C 17/002 (2013.01 - EP US); **C03C 17/25** (2013.01 - EP US); **C03C 2217/23** (2013.01 - EP US); **C03C 2218/113** (2013.01 - EP US)

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)

EP 2581351 A1 20130417; **EP 2581351 A4 20141231**; JP WO2011155543 A1 20130801; TW 201219330 A 20120516; US 2013098113 A1 20130425; US 8973403 B2 20150310; WO 2011155543 A1 20111215

DOCDB simple family (application)

EP 11792500 A 20110608; JP 2011063178 W 20110608; JP 2012519420 A 20110608; TW 100120361 A 20110610; US 201213710780 A 20121211